## 504622956 11/01/2017

# PATENT ASSIGNMENT COVER SHEET

Electronic Version v1.1 Stylesheet Version v1.2 EPAS ID: PAT4669674

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

#### **CONVEYING PARTY DATA**

Name	Execution Date
XIANG ZHENG TU	11/01/2017

#### **RECEIVING PARTY DATA**

Name:	POSIFA MICROSYSTEMS INC.
Street Address:	1925 ZANKER ROAD
City:	SAN JOSE
State/Country:	CALIFORNIA
Postal Code:	95112

### **PROPERTY NUMBERS Total: 1**

Property Type	Number
Application Number:	14933982

#### **CORRESPONDENCE DATA**

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Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

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ATTORNEY DOCKET NUMBER:	1119.P0001D1
NAME OF SUBMITTER:	JAMES M WU
SIGNATURE:	/James M. Wu/
DATE SIGNED:	11/01/2017

**Total Attachments: 2** 

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PATENT 504622956 REEL: 044011 FRAME: 0512

Attorney Docket No.: 1119.P0001D1

ASSIGNMENT

WHEREAS, I, Xiang Zheng Tu, a citizen of Canada, residing at 6708 Mt. Pakron

Dr., San Jose, CA, 95120, USA, have made an invention in:

VACUM-CAVITY-INSULATED FLOW SENSORS

for which I have executed application papers for a U.S. patent with a US Patent

Application serial No. 14/933,982; and

WHEREAS, POSIFA MICROSYSTEMS INC., a Corporation, having a place of

business located at 1925 Zanker Road, San Jose, CA, 95112, USA, is desirous of

acquiring the exclusive right, title and interest in and to said invention and in and to the

Letters Patent to be granted and issued therefore in the United States of America and its

territories and possessions, and all countries foreign thereto;

NOW, THEREFORE, for a valuable consideration, the receipt of which is hereby

acknowledged, I, Xiang Zheng Tu do sell, assign, transfer and set over unto the said

POSIFA MICROSYSTEMS INC., its successors and assigns the full and exclusive right,

title and interest in and to said invention, and in and to any and all Letters Patent to be

granted and issued therefore, not only for, to and in the United States of America, its

territories and possessions, but also for, to and in all other countries including all priority

rights under the International Convention; and we hereby authorize and request the

Commissioner of Patents and Trademarks to issue said Letters Patent to said POSIFA

MICROSYSTEMS INC., its successors and assigns, in accordance with this Assignment.

IN TESTIMONY WHEREOF, I have hereunto signed our names on the date indicated

hereinafter:

Re: U.S. Patent Application entitled:

VACUM-CAVITY-INSULATED FLOW SENSORS

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PATENT REEL: 044011 FRAME: 0513

Attorney Docket No.: 1119,P0001D1

1) Inventor: Xiang Zheng Tu	
Signature: Xiang Zheng Tu	Date: 11/1/2012
Witness: Peng Tu	Date: ////20/3
Witness:	Date: